

Docket: TSMC 01 - 144
S/N; 10/086,258

image

1762



To: Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

From: George O. Saile, Reg. No. 19,572
28 Davis Avenue
Poughkeepsie, N.Y. 12603

Subject:

| | |
|---|-------------------------|
| Serial No.: 10/086,258 | Filed: 03/04/2002 |
| Inventor: Ming-Hwa Yoo | |
| Title: A Novel Method to Solve IMD-FSG Particle and Increase Cp Yield by Using a New Tougher UFUN Season Film | |
| Group Art Unit: 1762 | Examiner: Chen, Bret P. |
| Attorney Docket: TSMC 01 - 144 | |

RESPONSE TO PATENT OFFICE ACTION

Dear Sir:

In response to the office action dated 12/04/03, please consider the following remarks:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on _____

March 4, 2004.

Signature/Date

3/4/04

Stephen B. Ackerman
Reg. No. 37,761